

## Effect of Metal on Characteristics of MPc Organic Diodes

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The fabrication and electrical characterization of metal phthalocyanine MPc organic diodes have been investigated. The Au / MPc / Si Schottky diodes are fabricated via a spin coating route. Based on the electrical measurement of the current versus bias voltage in dark conditions we extract the parameters such as ideality factor, saturation current, series resistance and rectifying factor. Role of metal M = Cu, Al, Zn, Mg on the electronic parameters is emphasized. The obtained values of  $n$ , 1.85, 2.22 and 4.40, show a non-ideal behavior. Using a derivate  $dV / d \ln I$  and  $H(I)$  functions, we determine the ideality factor and series resistance and found to be 2 and  $17 \Omega$  for the CuPc device.

**Keywords:** Organic layers, Spin coating, Current-voltage characteristics, Ideality factor, Barrier height.

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### 1. INTRODUCTION

Since 2001 organic materials attracted the attention of many researchers in order to fabricate a device with suitable electronic parameters and important efficiency. Metal phthalocyanine (MPc) where M = Cu, Al, Mg, Ni has been used as layers in the device fabrication [1-4]. Junctions and Schottky diodes are fabricated by many processes like thermal evaporation and spin coating [4-5]. Among the organic device materials, metal phthalocyanine is the typical one as mentioned by Yunfen [6]. In the current work, the synthesis and the diode formation of semiconductors from the reaction of metal phthalocyanine MPc(M = Cu, Mg, Al) are achieved. Many electronic parameters such as ideality factor, saturation current, rectification factor, series resistance and barrier height are then extracted for the Schottky barrier height (SBH) based on MPc material in dark conditions. Functions, like  $dV / d \ln I$  and  $H$  versus current, are plotted and some electronic magnitudes are determined.

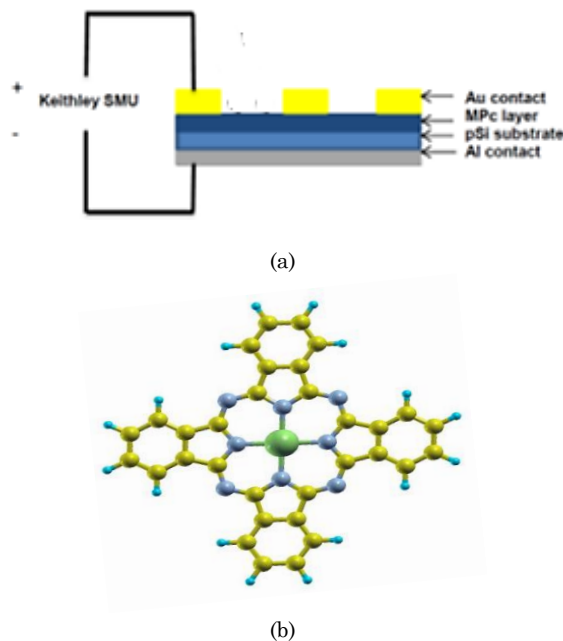
### 2. EXPERIMENTAL DETAILS

The Au/CuPc/pSi/Al, Au/MgPc/pSi/Al and Au/AlPc/pSi/Al diodes are fabricated by spin coating route @ 2000 rpm. Metallic contacts are made by thermal evaporation process in vacuum at pressure of  $10^{-6}$  T. The metallic (Au) contacts have a diameter of 1.5 mm. The cross section of Au/MPc/pSi/Al structures is sketched in figure 1. Experimental system for the diode fabrication and electrical characterization system are composed by a source meter unit SMU Keithley Model 2400. All the measurements are carried out at room temperature in dark conditions.

### 3. RESULTS AND DISCUSSION

The molecular structure of MPc has a square-planar arrangement with a metal ion in its center as displayed in figure 1A. Figure 2 depicts the semilog plotting versus bias voltage which varies within (-3, +3) V for the MPc / pSi diodes. The measurements are achieved in dark and at room temperature. From these characteristics, we extract the microelectronic parameters like ide-

ality factor, saturation current, rectifying factor and series resistance. Table 1 summarized all obtained parameters of the current-voltage characteristics. As shown in figure 2, the characteristics reveal a non-ideal behavior, a big discrepancy in current values is observed between CuPc, MgPc and AlPc in particular for the forward bias. At high voltage + 3 V, the current is found to be 152, 2 and 0.21 mA respectively for CuPc, MgPc and AlPc diodes. In the reverse bias region, 53.7, 0.26 and 0.34  $\mu$ A are the found current values at -3 V for the organic diodes cited above in the same order. At 0 V, the diode based on MPc shows roughly a current of 2.9  $\mu$ A, 0.24 nA and 1.6 nA respectively for M = Cu, Mg and Al.



**Fig. 1** – A cross section schematic cross-section of the Au/MPc/pSi/Al structures where M = Cu, Mg and Al (a) Molecular structure of MPc molecule (the metallic ion is green located in center) (b)

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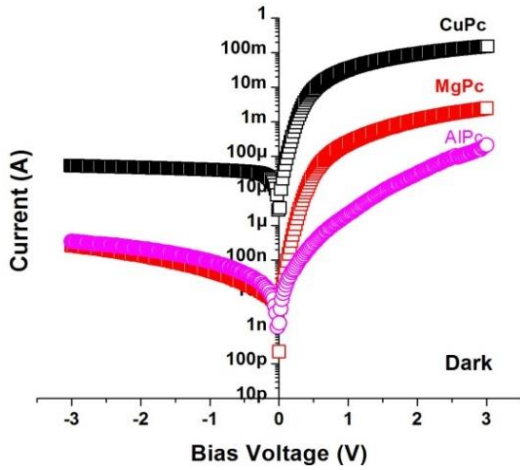


Fig. 2 – The semilog-plotting of I-V characteristics (under dark) of Al/MPc/p-Si diode, where M = Cu, Mg and Al

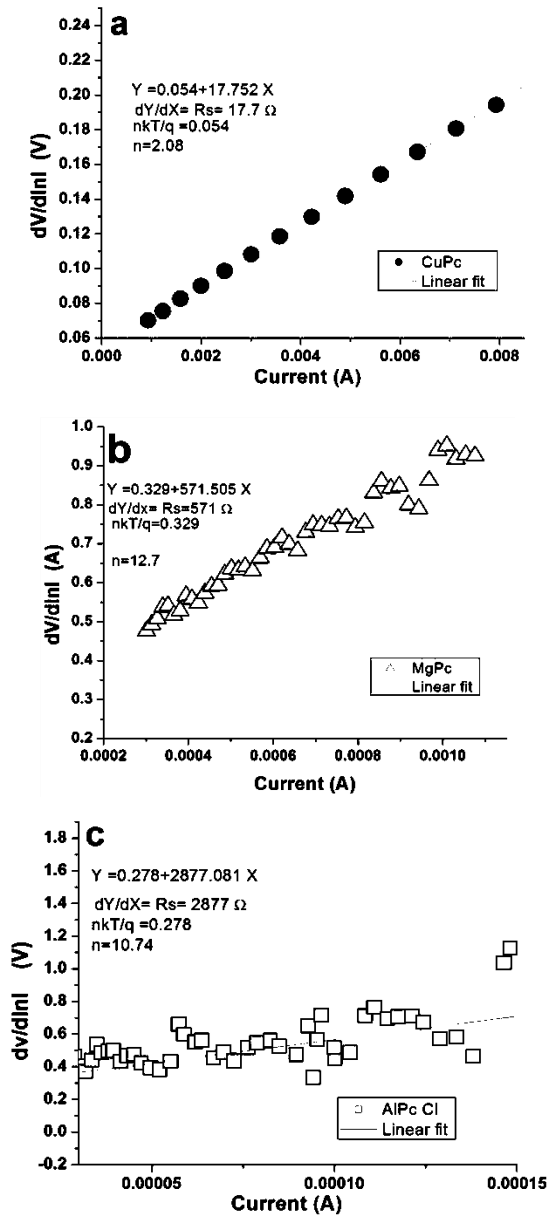


Fig. 3 –  $dV / d\ln I$  vs. current profile (under dark) of Al/MPc/p-Si diode, where M = Cu (a), Mg (b) and Al (c)

If the bias value is  $> 3kT / q$  then the ideality factor is calculated from the linear region of the current-voltage characteristics as follows [4];

$$n = \frac{q}{kT} \frac{dV}{d\ln(I)} \quad (1)$$

Where  $k$  is Boltzmann constant ( $1.38 \cdot 10^{-23}$  J/K),  $T$  is the absolute temperature (300 K) and  $q$  is the electron charge. The parameter  $n$  is equal to unity in the ideal diode case but for our Au/MPc/Si device it is greater than 1 due to interface density and series resistance. It is equal to 2.22, 1.85 and 4.40 respectively for  $M = \text{Cu, Mg and Al}$ . A rectifying behavior is then observed and rectifying factor  $R$  is calculated from ratio of current calculated at 3 V to that at  $-3$  V,  $R = I(3 \text{ V}) / I(-3)$  as listed in table 1.

According to the thermo-ionic emission mechanism, the current versus voltage depending on  $I_0$  is expressed as follows [6],

$$I = I_0 \exp\left[\frac{q(V - IR_s)}{nkT}\right] \quad (2)$$

The saturation current, depends on metallic ion  $M$  as indicated in table1, decreases strongly from 12  $\mu\text{A}$  to 7 nA when copper ion is substituted by magnesium or aluminum. As reported above, the non-ideal behavior of as fabricated diodes is revealed and rectification factor is higher for the Cu and Mg-Pc and lower for the AlPc as calculated in table 1 and shown in fig. 2.

When the effect of resistance is important, then the equation 1 will be modified as follows [4];

$$\frac{dV}{d\ln I} = R_s I + n \left( \frac{kT}{q} \right) \quad (3)$$

Here, the resistance due to the interface presence is dominated.

The derivate  $dV / d\ln I$  versus current is displayed in figure 3 a, b and c. From these curves, using a linear fit as  $(nkT / q) + R_s I$ , we determine the values of series resistance and idealty factor.  $n$  takes the values of 2.08, 12.7 and 10.74 and  $R_s$  of 17.7, 571 and 2877  $\Omega$  respectively for CuPc, MgPc and AlPc devices.

In contrast, when the resistance effect dominates, the two parameters  $\Phi_B$  and  $R_s$  are determined from the function  $H(I)$  expressed as [7];

$$H(I) = V - \left( \frac{nkT}{q} \right) \ln\left( \frac{I}{AA^* T^2} \right) \quad (4)$$

$A^*$  is of 32  $\text{A}/\text{cm}^2\text{K}^2$  for p type Si. The metallic contacts have an area of 0.0176  $\text{cm}^2$  and  $T$  is of 300 K and  $kT / q$  is found to be 0,025875 V.

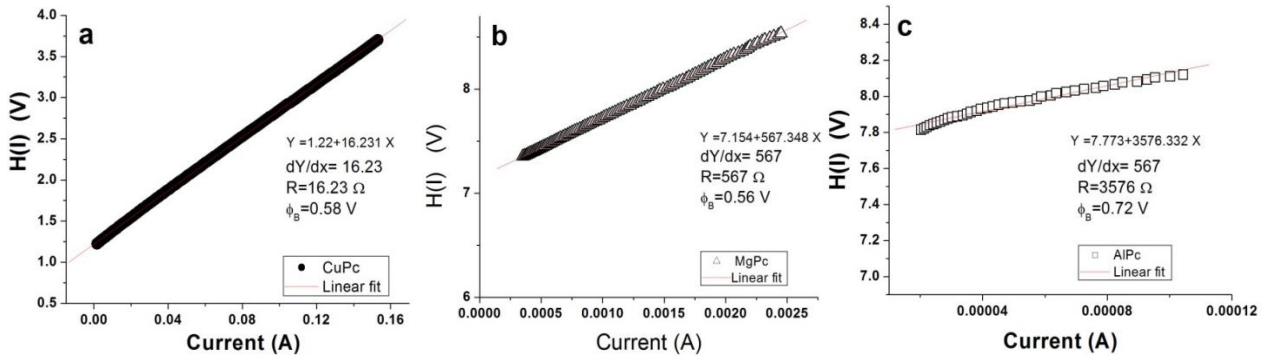
$$H(I) = n\Phi_B + R_s I \quad (5)$$

The  $H$  curves exhibit a linear variation as function of current as seen in figure 4. From the linear fit,  $Y = \alpha + R_s X$ , displayed in figure 4 and according to eq. 5 the parameters  $R_s$  and  $\Phi_B$  are determined as listed in table 1.

The series resistance  $R_s(\Omega)$  determined by the eq. 3, 4 and 5 are roughly close.  $R_s$  is around 17 $\Omega$  for the

**Table 1** – Ideality factor, saturation current, rectification factor, series resistance and barrier height

| MPC  | $n$<br>low voltage<br>( $V > 3kT/q$ ) | $I_0$<br>(A)         | $R$  | $R_s$<br>( $\Omega$ )<br>From<br>$dV/d\ln I$ | $R_s$<br>( $\Omega$ )<br>From $H(I)$ | $\Phi_B$<br>(V) |
|------|---------------------------------------|----------------------|------|--|--------------------------------------|-----------------|
| CuPc | 2.22                                  | $1.24 \cdot 10^{-5}$ | 2850 | 17.7   | 16.2                                 | 0.58            |
| MgPc | 1.85                                  | $7.42 \cdot 10^{-9}$ | 7650 | 571  | 567                                  | 0.56            |
| AlPc | 4.40                                  | $8.02 \cdot 10^{-9}$ | 624  | 2877   | 3576                                 | 0.72            |

**Fig. 4** – Plotting of  $H(I)$  vs. current (under dark) of Al/MPC/p-Si diode, where  $M = \text{Cu}$  (a),  $\text{Mg}$  (b) and  $\text{Al}$  (c)

CuPc device and greater than  $3500 \Omega$  for the AlPc device. Consequently the resistance decreases as a result of metal ion insertion. While the barrier height, is close for the MPC  $M = \text{Cu}$ ,  $\text{Mg}$ , and  $0.72 \text{ V}$  for AlPc diodes.

#### 4. CONCLUSION

The Au/MPC/Si diodes are successfully fabricated and investigated. The non-ideal behavior, metal ion dependence are revealed. A rectifying behavior of MPC diodes is confirmed  $8000 > R > 600$ , and  $n$  is greater than 2. This fact is due in particular to series resistance of CuPc device and greater than  $3500 \Omega$  for the AlPc device. Consequently the resistance decreases as a result of metal ion insertion. While the barrier height, is close for the MPC,  $M = \text{Cu}$ ,  $\text{Mg}$ , and  $0.72 \text{ V}$  for AlPc diodes,

and  $R_s$  varied within the range  $17\text{-}3500 \Omega$ . A barrier height of Au/MPC/Si is around  $0.6 \text{ V}$  and increases up to  $0.7 \text{ V}$  for the AlPc diode case.

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